

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Trung T. Doan
Title: CHEMICAL DISPENSING SYSTEM FOR SEMICONDUCTOR WAFER PROCESSING
Docket No.: 303.928US5 Serial No.: 09/652,713
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Examiner: Sylvia MacArthur Group Art Unit: 1792

MS Appeal Brief - Patents


Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

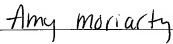
☒ Reply Brief under 37 C.F.R. 41.41 (4 pgs.).

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(GENERAL)